

In re Application of:
Butterfield et al.

Confirmation No.: 9303

Filed: June 26, 2003

For: ☐ Conductive Polishing Article
☐ For Electrochemical
☐ Mechanical Polishing

Group Art Unit: 1753

Examiner: Arun S. Phasge

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, or electronically transmitted to the U.S. Patent and Trademark Office via EFS-Web to the attention of Examiner Phasque, on the date shown below.

Date 3/6/07 Steven H VerSteege

RESPONSE TO OFFICE ACTION DATED JANUARY 10, 2007

In response to the Office Action dated January 10, 2007, having a shortened statutory period for response set to expire on April 10, 2007, please enter this response and reconsider the claims pending in the application for the reasons discussed below. Although Applicants believe that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/004100.P7/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Specification begin on page 2 of this paper. **Amendments to the Claims** are reflected in the listing of claims which begins on page 13 of this paper. **Remarks** begin on page 23 of this paper.